



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

December 19, 2025

IGI Report Number **LG758576916**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **OVAL BRILLIANT**

Measurements **10.78 X 7.41 X 4.64 MM**

GRADING RESULTS

Carat Weight **2.30 CARATS**

Color Grade **E**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG758576916**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG758576916
Report verification at igi.org

LABORATORY GROWN DIAMOND REPORT



December 19, 2025

IGI Report Number

LG758576916

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

10.78 X 7.41 X 4.64 MM

GRADING RESULTS

Carat Weight

2.30 CARATS

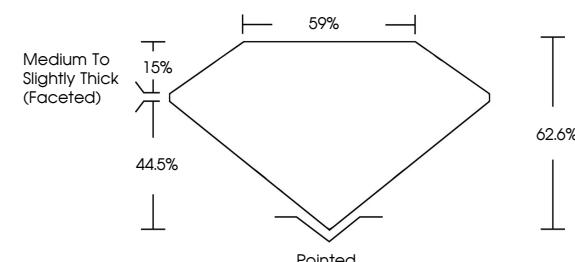
Color Grade

E

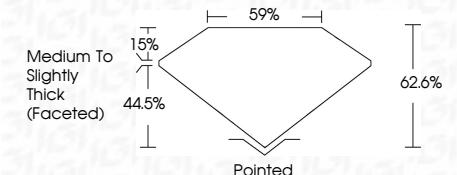
Clarity Grade

VVS 2

PROPORTIONS



Sample Image Used



COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
---	---	---	---	---	---	---	-------	------------	-------

CLARITY

FL	IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
----	----	-------------------	-------------------	-------------------	------------------

Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included
----------	---------------------	-----------------------------	------------------------	-------------------	----------

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG758576916**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa



© IGI 2020, International Gemological Institute

FD - 10 20

www.igi.org



December 19, 2025	IGI Report No LG758576916
	OVAL BRILLIANT
	10.78 X 7.41 X 4.64 MM
	2.30 CARATS
	E
	VVS 2
	62.6%
	59%
	Medium To Slightly Thick (Faceted)
	Pointed
	EXCELLENT
	EXCELLENT
	NONE
	IGI LG758576916

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa